

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

SHAFQAT AHMED, ET AL.

Application No.:

Filed:

For: **Method of Forming Transistor Having  
Insulating Spacers On Gate Sidewalls**

Art Group: 2822

Examiner: Soward, Ida M.

**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure, enclosed is a copy of Information Disclosure Statement by Applicant (form PTO/SB/08), which is being submitted concurrently with the Divisional Application. It is respectfully requested that the cited references be considered and that the enclosed copy of PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s). Some or all of the references listed on the enclosed PTO/SB/08 were previously identified in the parent application (Application No. 10/247,027, filed September 19, 2002) and copies of the references were furnished at that time. Accordingly, per 37 CFR §1.98(d)(1) additional copies of those references are not submitted herewith.

The submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made in the subject application and is not to be construed as an admission that the information cited in this statement is material to patentability.

Please charge any fees due to Deposit Account 02-2666. A duplicate copy of the Fee Transmittal (PTO/SB/17) is enclosed for this purpose.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: July 15, 2003

Brent E. Vecchia  
Brent E. Vecchia, Reg. No. 48,011

12400 Wilshire Blvd., 7th Floor  
Los Angeles, California 90025  
(303) 740-1980

Krista Mathieson July 15, 2003  
Krista Mathieson Date

US Department of Commerce  
Patent and Trademark Office

Form PTO-1449 (Modified)

Atty. Docket No.:

42390P13230

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10/247,027

Applicant:

Ahmed, et al.

Filing Date:

September 18, 2002

### US Patent Documents

Examiner's Initials	Date	Document Number	Name	Class	Sub- Class	Filing Date
	04/12/94	5,302,555	Yu			
	05/07/91	5,013,691	Lory, et al.			
	08/06/96	5,543,654	Dennen			
	01/20/98	5,710,450	Chua, et al.			
	02/03/98	5,174,413	Brigham, et al.			
	07/14/98	5,780,912	Burr, et al.			
	06/01/99	5,908,313	Chau, et al.			
	11/02/99	5,976,939	Thompson, et al.			
	07/25/00	6,093,610	Rodder			
	09/19/00	6,121,100	Andideh, et al.			
	12/26/00	6,165,826	Chau, et al.			
	03/06/01	6,198,142	Chau, et al.			
	09/25/01	6,294,823	Arafa, et al.			
	10/23/01	6,306,712	Rodder, et al.			

### Foreign Patent Documents

Examiner's Initials	Date	Document Number	Country	Class	Sub- Class	Translation

### Other Documents (Including Author, Title, Date, Pertinent Pages, etc.)

Examiner	Date Considered	

Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw a line through the citation if not in conformance and not considered. Include a copy of this form with the next communication to the applicant